

**Search Notes**

Application/Control No.

09/829,793

Applicant(s)/Patent under  
ReexaminationEMONS, MARTIJN  
JOHANNES LAMBERTUS

Examiner

Hong C. Kim

Art Unit

2185

**SEARCHED**

Class	Subclass	Date	Examiner
711	138	11/26/05	cdk
713	324		
See Attachment			

**INTERFERENCE SEARCHED**

Class	Subclass	Date	Examiner
See Attachment		11/26/05	cdk

**SEARCH NOTES  
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
EAST	11/26/05	cdk